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Part II: Experimental Exploration of the
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A MEMS Singlet Oxygen Generator—Part II: Experimental Exploration of the Performance Space

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Abstract—This paper reports the quantitative experimental exploration of the performance space of a microfabricated singlet oxygen generator (µSOG). SOGs are multiphase reactors that mix H₂O₂, KOH, and Cl₂ to produce singlet delta oxygen, or O₂(α). A scaled-down SOG is being developed as the pump source for a microfabricated chemical oxygen-iodine laser system because scaling down a SOG yields improved performance compared to the macroscaled versions. The performance of the µSOG was characterized using O₂(α) yield, chlorine utilization, power in the flow, molar flow rate per unit of reactor volume, and steady-state operation as metrics. The performance of the µSOG is measured through a series of optical diagnostics and mass spectrometry. The test rig, which enables the monitoring of temperatures, pressures, and the molar flow rate of O₂(α), is described in detail. Infrared spectra and mass spectrometry confirm the steady-state operation of the device. Experimental results reveal O₂(α) concentrations in excess of 10⁻¹⁷ cm⁻³, O₂(α) yield at the chip outlet approaching 80%, and molar flow rates of O₂(α) per unit of reactor volume exceeding 600 × 10⁻⁴ mol/Ls.

Index Terms—Chemical oxygen iodine laser (COIL), infrared (IR) diagnostics, microfluidics, singlet delta oxygen, singlet oxygen generator (SOG).

I. INTRODUCTION

Singlet delta oxygen [O₂(a¹Σg) or O₂(α)] is a spin-excited molecule that is useful for many different applications. It differs from ground-state [triplet, O₂(X³Σ⁻)] or O₂(X) oxygen in that the number of valence of electrons in each spin state is balanced, resulting in an energy difference of 22.5 kcal/mol between the two states [1]. Chemical oxygen iodine lasers (COILs) are flowing gas lasers that use O₂(α) to pump I²P₁/₂ to the higher I²P₁/₂ state, from which it then lases at 1.315 µm. COILs are scalable to high powers, making them an attractive alternative to CO₂, hydrogen fluoride, and deuterium fluoride lasers for applications requiring high power and a wavelength that can be transmitted through conventional glass optics. The wavelength also results in a smaller spot size than that of the 10.6-µm wavelength CO₂ system, leading to better resolution and accuracy at higher powers. Since the gain medium is continually and rapidly pumped through the system, the power is not limited by cooling of the lasing medium as it is in solid-state laser systems such as the Nd:YAG [2]. The COIL system is scalable to an average power output in excess of 1 MW [3]. As discussed in Part I of this paper [4] and in [5], singlet oxygen generators (SOGs) produce O₂(α) through a chemical reaction between gaseous Cl₂ and an aqueous mixture of concentrated H₂O₂ and KOH, also known as basic hydrogen peroxide (BHP).

This paper extends the experimental proof of concept provided in Part I (dimol emission, infrared (IR) spectra, and correlation of chlorine injection with oxygen generation) by systematically exploring the operational space of the microfabricated SOG (µSOG) to address whether the device reaches steady state and whether the chlorine is fully reacted, and to determine the highest yield, concentration, and molar flow rate of O₂(α). It was expected that µSOGs would perform better than their macroscale counterparts because reducing the dimensions of the reactor both increases the reaction efficiency (as surface-to-volume ratio increases) and reduces the O₂(α) losses (as residence time in the auxiliary flow paths decreases). The set of measurements described here is intended to confirm this hypothesis. The experimental characterization is made using spectroscopy of the O₂(α) dimol emission, spectroscopy of the spontaneous emission of the O₂(α → X) system, and mass spectrometry of the gaseous byproducts. This experimental characterization of the SOG for a COIL system utilizes a direct approach to measure O₂(α) production. It is typical in the COIL field to benchmark the performance of the full COIL by metrics such as small signal gain of the laser, and then extract the SOG performance from models that incorporate the complex internal reactions of the COIL subsystems. In contrast, this paper employs a direct rigorous experimental benchmarking of the pump reactor for a COIL system as an independent entity.

II. PERFORMANCE CRITERIA AND TESTING METHODOLOGY

Beyond simply producing O₂(α), there are several other requirements for the SOG for a COIL system, and several metrics by which SOGs are judged in the COIL community. First, the SOG must ensure that as much of the product O₂ is possible is in the O₂(α) state. This is measured by the yield,
which is the fraction of O$_2$ in the singlet delta state at a given point in the system. A positive gain COIL system was first demonstrated by McDermott et al. in 1978, with a yield of about 40% [6]. Second, the percentage of Cl$_2$ converted into O$_2$ (also called the chlorine utilization) should approach 100%, as any unreacted Cl$_2$ can deactivate the excited I atoms and impede laser operation. Third, the SOG hardware must be as compact as possible for a given output flow of O$_2$(a). The authors propose that an appropriate performance metric for compactness is the molar flow rate of O$_2$(a) per unit of reactor volume; a high value of this metric in this case would indicate that an array of microelectromechanical systems (MEMS)-based SOGs could produce a total output of O$_2$(a) that exceeds that of a comparably sized macroscaled SOG. Fourth, the SOG must operate at a low temperature to minimize the amount of water vapor in the output gas flow; water vapor can also deactivate excited I atoms. Fifth, and as described in Part I, the SOG must effectively separate out the liquid byproducts from the gaseous output flow. Finally, the SOG should operate in the steady state given steady-state inputs (pressures, flow rates, and temperatures).

The values of the SOG performance metrics described above have a complex dependence on the flow rates, pressures, and temperatures at different points in the system because these parameters, in turn, impact residence times, the rate of deactivation of O$_2$(a) by various mechanisms, and whether the KCl reaction products are at sufficient concentration to crystallize and clog the reactor. Precise control and measurement of the operating conditions are necessary in order to fully characterize the SOG performance over the parameter range of interest. The testing apparatus that enables the measurement and control of these parameters is described in Section III, along with the apparatus for measurement of oxygen populations.

A range of diagnostics is required to measure the resulting SOG performance. The simplest of these diagnostics is flow visualization using a microscope and camera. The flow is visualized in the flow distribution channels, the reaction channels, and the capillary separator.

Although it is relatively straightforward to confirm O$_2$(a) generation [4], quantitatively measuring the O$_2$(a) and yield pose significant challenges. Typically, SOG performance is determined in the context of a complete COIL system; heuristics are used to estimate yield from small signal gain and laser output along with various losses and efficiencies in the system [7]. In this paper, a suite of more direct diagnostics is instead employed to obtain both quantitative and qualitative information on the O$_2$(a) population.

Production of O$_2$(a) can be confirmed by observing the red glow of the O$_2$(a) dimol emission, either visually as described in Part I or through spectroscopy. The exact mechanism is unknown but has been postulated as

$$2\text{O}_2(\text{a}) \rightarrow \text{O}_4^* \rightarrow \text{O}_4 + h\nu \rightarrow 2\text{O}_2(\text{X}). \quad (1)$$

This emission produces photons of wavelengths 634 and 703 nm, depending on the vibrational state of the resulting O$_2$(X) molecules, thus falling into the visible range [8]. However, since the dimol emission rate varies with pressure and other factors, drawing quantitative conclusions from it is difficult [9]. In contrast, the decay of solitary O$_2$(a) molecules into the triplet state, which produces photons in a molecular band centered at 1268 nm, can be used to determine O$_2$(a) concentration because there is a one-to-one relationship between the photon emission rate and the number of O$_2$(a) molecules in the field of view. By normalizing the O$_2$(a) concentration by the initial Cl$_2$ concentration, the product of the O$_2$(a) yield and the chlorine utilization can be determined. One method of determining chlorine utilization is to analyze the gaseous byproducts of the SOG, for example, by mass spectrometry, to determine the total oxygen in the flow. Comparing the total oxygen output to the chlorine input yields the chlorine utilization. Alternatively, the O$_2$(a) concentration and yield-utilization product just after O$_2$(a) production can be estimated from the concentration and yield-utilization product at the measurement point and models of the deactivation of O$_2$(a) en route to the measurement point. This estimated value of the yield-utilization product is a lower bound on the value of the chlorine utilization.

One final aspect of the test methodology for this paper is the use of detailed quantitative models of the SOG to better understand and describe its performance. These include models of the reaction channels, models of the O$_2$(a) loss mechanisms in the outlet flow paths, and models of the supporting subsystems such as the heat exchangers and the capillary separator. These models are described in detail in Section IV, and their application to the analysis of the results is presented in Section VII.

III. TESTING APPARATUS

A. Packaging

The completed devices were packaged using a Tefzel chuck and Teflon tubing. The plates have machined ports that allow for the reactants and products to enter and exit the chip. Kalrez o-rings enable leak-free operation of the chip over a range of pressures and easy chip assembly to the testing facility. The package materials were chosen for their chemical resistance to BHP and chlorine. For the connection to the chip’s gas outlet port, quartz surfaces were chosen in part to minimize O$_2$(a) deactivation. The packaging scheme is described in greater detail in Part I [4].

B. Testing Rig

All experiments were performed inside a ventilated cabinet because of the toxic and corrosive nature of chlorine gas and BHP. The BHP is stored in a glass-lined stainless steel pressurized reservoir. The BHP is pressure-fed to the chip by introducing He into the vessel that contains the BHP. The helium pressure (and thus, the BHP flow rate) is regulated by a pressure controller (MKS Instruments, Wilmington, MA). The BHP reservoir and µSOG package are connected using Teflon tubing and Upchurch PEEK connectors. The liquid byproducts coming out of the chip are collected in a second reservoir. Both reservoirs were maintained at temperatures between $-20$ °C and $-10$ °C to minimize BHP decomposition. Ensuring that the
BHP is properly cooled is critical for safety; at temperatures above 50 °C, H₂O₂ decomposition is accelerated, and the solution can be explosive. Temperatures throughout the testing rig are monitored using thermocouples. Compressed tanks of Cl₂ and He are stored in a cabinet below the experiment, and gas flow to the chip is controlled by mass flow controllers and manual valves. The majority of gas connections preceding the chip use stainless steel tubing and Swagelok connectors. The connections immediately preceding and following the µSOG package are made with Teflon tubing, which was chosen for its flexibility and low reactivity with BHP. Before reaching the vacuum pump, both µSOG exit lines (one for gaseous products and one for liquid byproducts) pass through liquid-nitrogen cooling traps in order to condense water vapor and unreacted chlorine. The gas outlet is then connected to a mass spectrometer through a glass capillary line, allowing sampling of a portion of the plenum stream. The entire setup is served by an external chiller (Julabo, Allentown, PA), which delivers a silicone-based cooling fluid (Syltherm, Dow Chemical, Midland, MI) to the system through Tygon tubing. Fig. 1 illustrates the main features of the testing rig.

**C. Oxygen Diagnostics**

Singlet delta oxygen concentration measurements were taken using quantitative spectroscopic techniques developed at Physical Sciences Inc., Andover, MA and also described in [10]. The test cell was a rectangular quartz cuvette (Starna, Atascadero, CA) that was connected to the µSOG plenum by a 0.2-cm diameter quartz tube. Collimated optics sampled a cylindrical cross section of the cuvette, yielding a 1.1-cm field of view. The cuvette and collimator are depicted in Fig. 2. In addition to the uncalibrated spectroscopy of the spontaneous O₂(a) decay described in Part I, a liquid-nitrogen-cooled InGaAs array spectrometer (Roper Scientific, Trenton, NJ) was used to analyze photons from the spontaneous emission. The intensity of the spectrometer signal was calibrated to the spectral radiance of a blackbody source at 1000 K. This setup is capable of acquiring a sequence of spectral scans separated by a predetermined integration time. Additionally, a third spectrometer was used to qualitatively measure the intensity of the dimol emission.

Finally, mass spectrometry measurements were made on samples taken from the gas exit line with the intent of using the rise in O₂ mole fraction to determine the degree of chlorine utilization, as described above. To this end, sample gas from the gas outlet flow path was collected by a silica capillary after passing through a liquid-nitrogen trap. The mass spectrometer, which had its intensity calibrated with an 80%/20% He/O₂ mixture, is able to detect constituent elements of the gas stream by first ionizing the molecules and then scanning for certain masses using a quadrupole mass filter.

**IV. SOG DESIGN AND MODEL**

The O₂(a) production model originates in a series of chemical reactions, which is given in Table I, that describe the interactions between reactants, products, and intermediate compounds. The reaction between Cl₂ and the BHP solution can be described by reactions R1b–R1e. There is significant uncertainty in the rate of the reaction between Cl₂ and BHP [11–13]. However, reaction R1b is generally considered to be the rate-limiting step. The mass transfer coefficient can therefore be described by

\[
\frac{k_L}{\sqrt{k_1 \cdot D_{Cl}_2 \cdot [O_2H^-]}}
\]

where \(k_1\) is the R1b reaction coefficient, \(D_{Cl}_2\) is the diffusivity of Cl₂ in BHP, and \([O_2H^-]\) is the peroxide ion concentration. Taking \(D_{Cl}_2\) to be \(9 \times 10^{-6}\) cm²/s [3] and \(k_1\) to be \(2.7 \times 10^{10}\) cm³/mol/s [14], the thickness of the BHP surface layer in which the chlorine reaction occurs is estimated to be about...
One quantity of interest is the rate of Cl\(_2\) consumption \(r_{\text{Cl}_2}\), which is expressed as

\[
r_{\text{Cl}_2} = k_L \cdot a \cdot [\text{Cl}_2]_g
\]

(3)

where \(k_L\) is the mass transfer coefficient, \(a\) is the surface area per unit volume, and \([\text{Cl}_2]_g\) is the chlorine concentration in the gas. This expression assumes that the reaction at the liquid interface is so rapid that the rate is mass transfer limited, and the interfacial concentration of chlorine is very small. This equation can be further simplified by applying the ideal gas law for the chlorine, which yields

\[
r_{\text{Cl}_2} = k_L \cdot a \cdot y_{\text{Cl}_2} \frac{P}{RT}
\]

(4)

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r_{\text{Cl}_2} = k_L \cdot a \cdot y_{\text{Cl}_2} \frac{P}{RT}
\]

(4)
where $P$ is the total pressure, $y_{Cl_2}$ is the chlorine molar fraction, $R$ is the universal gas constant, and $T$ is the temperature of the gas. After the $O_2(a)$ is produced, it diffuses out of the BHP and into the gas phase. The rate of increase of $O_2(a)$ in the gas phase is given by

$$r_{O_2(a)} = k_L \cdot a \cdot \chi_{\text{detach}} \cdot \frac{y_{Cl_2} \cdot P}{RT} + B \left( \frac{P}{n_i RT} \right)^2 \tag{5}$$

where $n_i$ is the total number of moles of the gas. The first term of (5) represents the liquid phase processes, including $Cl_2$ conversion, whereas the second term reflects the gas phase deactivation mechanisms described in Table I. The first term is similar to the chlorine consumption described in (4), but with the addition of the factor $\chi_{\text{detach}}$ that describes the percentage of generated $O_2(a)$ that appears in the gas phase. Some of the $O_2(a)$ molecules are deactivated according to reaction $R1e$ as they diffuse back across the 10-nm reaction depth to the liquid/gas interface; additionally, a portion of the $O_2(a)$ molecules that reach the liquid/gas interface diffuse back into the bulk liquid and are quenched. Several approaches to determining the detachment yield have been described in the literature [11], [12], [15]–[17]. These approaches produce similar but not identical estimates of detachment yield by describing similar mechanisms in various levels of detail. In all of these approaches, uncertainties in the physical constants (for example, as reported in [13], [15], and [18]–[21]) can result in significant uncertainties in the calculated detachment yields. In this paper, an initial estimate of the $O_2(a)$ loss due to liquid phase deactivation was made by comparing the timescale for $O_2(a)$ quenching in the liquid to the timescale for $O_2(a)$ diffusion back through the reaction layer [15]. Assuming that the diffusivities of oxygen and chlorine in BHP are $10^{-5}$ cm$^2$/s, the deactivation timescale is 40 times greater than the diffusion time, suggesting a loss of about 2.5% of the $O_2(a)$ en route to the liquid/gas interface. A more detailed approximation of $\chi_{\text{detach}}$ was obtained using the method of [11]. This approach takes into account both the deactivation by $R1e$ and the surface detachment processes [11], [16], [17]. Using the same values for the diffusivities that are used above, this produces a $\chi_{\text{detach}}$ of 94%; alternatively, using the parameter values given in [11] would produce a $\chi_{\text{detach}}$ of 90%. These methods suggest that the detachment yield is in the range of 90%–97.5%. Although a 5% to 10% yield loss corresponds to a large difference in $O_2(a)$ concentration in the reaction channels themselves, the change in concentration at the measurement point is only on the order of $10^{14}$ cm$^{-3}$ because of gas phase deactivation. This difference is well below the detection limit of the optical emission diagnostic. As a result, the model used here approximates $\chi_{\text{detach}} = 1$. The coefficient $B$ in the second term can be expressed as

$$B = -2k_2y_{O_2(a)}^2 - 2k_3y_{O_2(a)} - k_4y_{O_{12}(b)}y_{O_2(a)} + k_5y_{O_{12}(b)}y_{He} + k_6y_{Cl_2}y_{O_2(b)} + k_7y_{Cl_2}y_{O_2(b)} + k_8y_{O_{12}(b)}y_{He} - k_9y_{O_2(a)}y_{O_2(b)} - k_{10}y_{O_2(b)}y_{He} - k_{11}y_{Cl_2}y_{O_2(a)} - k_{12}y_{O_2(a)}y_{He} \tag{6}$$

where $y_e$ is the molar fraction of the species $x$, and each $k$ coefficient is the particular reaction constant between two certain species, as given in Table I. The pressure drop across the reaction channels is modeled using the equation of Ergun [22], which is written for gases as

$$\left. \frac{dP}{dz} \right|_g = -\frac{F_i \cdot RT}{D_p \cdot P \cdot a_c} \cdot \left( \frac{1 - \varepsilon}{\varepsilon^3} \right) \cdot \left[ 150 \cdot (1 - \varepsilon) \cdot \mu_g + 1.75 \cdot MW_g \cdot \frac{F_i \cdot RT}{P \cdot a_c} \right] \tag{7}$$

where $z$ is the distance along the reaction channel, $F_i$ is the total molar flow rate (constant), $D_p$ is the packing diameter in the channels, $a_c$ is the cross-sectional area of the reaction channels, $\varepsilon$ is the void fraction, $\mu_g$ is the viscosity of the gas, and $MW_g$ is the molecular weight of the gas. A similar relationship between liquid flow and differential pressure drop in the reaction channels also exists. Assuming ideal plug flow in the channels, the relationship between molar flow rate $F_i$ and species production rate $F_i$ for a species $i$ is

$$\frac{1}{\varepsilon_g \cdot a_c} \cdot \frac{d(F_i)}{dz} = r_i \tag{8}$$

where $\varepsilon_g$ is the fraction of the volume in the reaction channels that is occupied by the gas phase. Substituting (5) into (8) yields

$$\frac{dF_{O_2(a)}}{dz} = \varepsilon_g \cdot a_c \cdot k_L \cdot \chi_{\text{detach}} \cdot \frac{y_{Cl_2} \cdot P}{RT} + \varepsilon_g \cdot a_c \cdot B \left( \frac{P}{F_i RT} \right)^2 \tag{9}$$

Similar expressions were obtained for the other reactants and reaction products. The kinetic model is discussed in more detail in [3].

Several modifications to the original model were made to analyze the data collected by the testing rig. The reactant properties, which were initially assumed to be similar to those of air and $H_2O$, were modified to more accurately represent BHP and $Cl_2$ [23]. Additionally, the $\mu$SOG dimensions were changed to reflect the fabricated device. Table II illustrates these changes.
A zero wetting angle is the maximum pressure drop that can exist across a capillary given in, and thus, the separator is pressure driven (Fig. 3, right). The steady-state flow configuration, the capillaries are fully filled capillary with a certain wetting angle effects, thus filling in the capillary. The liquid will wet the surface of the liquid byproducts gets sucked in due to surface tension effects, thus surface tension forces are predominant in the separator region. The separator, which is first described in [24] and [25], relies on capillary action to remove the liquid byproducts without the need for an external pressure signal. For 20-µm-wide capillaries and given the surface tension of water (72 dyn/cm), the maximum pressure drop that the meniscus can withstand is 108 torr. A second expression for pressure can obtained from the Hagen–Poiseuille equation if steady-state fully developed flow is assumed and the liquid is Newtonian, with pressure losses produced by viscosity. In this case, the volumetric flow rate $Q$ through each capillary is given by [26]

$$\Delta P = \frac{4\Sigma}{\phi}$$  \hspace{1cm} (10)

where $\Sigma$ is the surface tension of the liquid, and $\phi$ is the diameter of the capillary. This value is also the maximum pressure that surface tension effects can provide to pump the liquid byproducts without the need for an external pressure signal. For 20-µm-wide capillaries and given the surface tension of water (72 dyn/cm), the maximum pressure drop that the meniscus can withstand is 108 torr. A second expression for pressure can obtained from the Hagen–Poiseuille equation if steady-state fully developed flow is assumed and the liquid is Newtonian, with pressure losses produced by viscosity. In this case, the volumetric flow rate $Q$ through each capillary is given by [26]

$$Q = \frac{\pi \Delta P \phi^4}{128 \mu L_c}$$  \hspace{1cm} (11)

where $\mu$ is the viscosity of the fluid, and $L_c$ is the channel length. For a given pressure drop across the separator, the number of pores needed to transport the liquid byproducts can be found by dividing the total liquid molar flow rate $Q_t$ by $Q$. $Q_t$ is expressed as

$$Q_t = \frac{\gamma \varphi y_{Cl_2}}{[O_2H^+]}$$  \hspace{1cm} (12)

where $\varphi$ is the total gas molar flow rate, $\gamma$ is the desired ratio of peroxide ions to Cl$_2$, and $y_{Cl_2}$ is the chlorine fraction of the entering gas stream. The original design called for a 10:1 peroxide ion to Cl$_2$ ratio and a peroxide ion concentration $[O_2H^+]$ of $6.5 \times 10^{-3}$ mol/cm$^3$. For a gas flow rate of 50 sccm, around 430 capillaries would be necessary; for a gas flow rate of 250 sccm, the number of capillaries necessary rises to about 2200. However, more than 7000 were included in the actual devices due to concerns about how many functioning pores would be produced in the deep reactive ion etching steps. In addition, it was desired to have some redundancy in the separator in case clogging occurred during testing of the chip.

B. Heat Exchanger

Because of the high enthalpy associated with the reaction, any O$_2$(a) generation system must include a heat removal mechanism. In the µSOG, this task is accomplished using a heat exchanger composed of 19 parallel cooling channels that are directly situated beneath the reaction area. The lower silicon layer of the MEMS chip contains the microfabricated heat exchanger. The heat exchanger channels are filled with a silicone-based coolant and are connected to an external chiller. Given an enthalpy of reaction of $-110$ kJ/mol and a maximum Cl$_2$ molar flow rate of $3 \times 10^{-5}$ mol/s in these experiments, the heat exchanger needs to be capable of removing at least 3.5 W of heat in order to remove the excess heat of reaction. In addition, in order to maintain the chip at a temperature that lies within BHP safety limits and restricts the amount of water vapor in the exit flow, which is important for overall COIL performance, the heat exchangers must also remove the heat that enters the chip from the ambient, which is estimated to be about 10 W for the present experimental setup and an operating temperature of $-5$ °C. In order to handle this task, the channels were sized at 23.9 mm in length and 300 µm wide. The heat removal capacity of the microfabricated heat exchanger was empirically verified before attempting to produce O$_2$(a). Using thermocouples to monitor the coolant and silicon temperatures, the specific heat equation was used to calculate the total heat removed. Fig. 4 illustrates the measured heat removal capacity of the channels as a function of the silicon temperature. The heat removal capacity $\Xi$ was calculated using the expression

$$\Xi = \dot{m} \cdot C_p \cdot \Delta T$$  \hspace{1cm} (13)
where \( \dot{m} \) is the mass flow rate of coolant, \( C_p \) is its heat capacity, and \( \Delta T \) is the temperature difference across the heat exchanger.

### C. Singlet Delta Oxygen Deactivation

Once \( O_2(a) \) has been created, it can be deactivated both inside the \( \mu \)SOG chip and in the external flow paths by collisions with other \( O_2(a) \) molecules (pooling reactions) and collisions with the walls of the flow path. The rates of the pooling reactions and the wall deactivation reactions depend, as described below, on the geometry and material composition of the chip’s internal gas exit path and the external flow path. The chip’s internal exit flow path has a length of 1.8 cm and a width of 2 mm, and its surface is silicon-rich silicon nitride, as described in Part I. Upon exiting the chip, the gas mixture pools in a quartz cuvette. The cuvette’s inlet is a 1-cm-long tube with an inner diameter of 2 mm, and it is connected by a 0.5-cm-long transition region to a diagnostic region that has a 1 x 1-cm square cross section. The rectangular portion features 1-mm-thick walls.

The mole fraction \( y_{O_2(a)}(a) \) in a rectangular volume as a function of flow length can be described as

\[
\frac{dy_{O_2(a)}}{dl} = \frac{-(2k_3 + k_2)P}{RTv_{\text{gas}}} y_{O_2(a)}^2
- \psi_w \frac{(W + H)}{2WH} \sqrt{\frac{8RT}{\pi\text{MW}_{O_2}}} y_{O_2(a)} \quad (14)
\]

where \( P \) is the total pressure of the gas, \( R \) is the universal gas constant, \( T \) is the gas temperature, \( v_{\text{gas}} \) is the flow velocity, \( W \) is the width of the flow path, \( H \) is the height of the flow path, \( \text{MW}_{O_2} \) is the molecular weight of oxygen, \( \psi_w \) is the \( O_2(a) \) deactivation coefficient for the particular wall material, and \( l \) is the dimension along the flow axis. The first term of (14) derives from the reactions described in (6); only the dominant terms are kept, and the rate of reaction 5 is taken to be large enough to make the net effect of reaction 2 be the deactivation of a single \( O_2(a) \) molecule. Equation (14) is the well-known Ricatti equation [27], which has the general form

\[
\frac{du(l)}{dl} + \Lambda(l) \cdot u(l) + \Theta(l) \cdot u^2(l) = \Omega(l) \quad (15)
\]

where \( u(l) \) is the function, and \( l \) is the independent variable. The transformation

\[
u(l) = \frac{dw(l)}{dl} / [\Theta(l) \cdot w(l)]
\quad (16)
\]

converts the nonlinear differential equation into the following homogeneous linear second-order ordinary differential equation:

\[
\frac{d^2w(l)}{dl^2} + \left[ \Lambda(l) - \frac{d\Theta(l)}{dl} / \Theta(l) \right] \frac{dw(l)}{dl} + \Omega(l) \cdot \Theta(l) \cdot w(l) = 0.
\quad (17)
\]

For the particular case of (14), the following equations were derived:

\[
\Lambda(l) = \Lambda = \psi_w \frac{(W + H)}{2WH} \sqrt{\frac{8RT}{\pi\text{MW}_{O_2}}} \quad (18)
\]

\[
\Theta(l) = \frac{(2k_3 + k_2)P}{RTv_{\text{gas}}} \frac{d\Theta(l)}{dl} = 0 \quad \Omega(l) = 0. \quad (19)
\]

Therefore, (17) simplifies to

\[
\frac{d^2w(l)}{dl^2} + \Lambda \cdot \frac{dw(l)}{dl} = 0. \quad (20)
\]

The solution of (20) is

\[
w(l) = C_1 e^{-\Lambda l} + C_2 \quad (21)
\]

where \( C_1 \) and \( C_2 \) are integration constants. Substituting (21) into (16), and applying the initial condition that \( y_{O_2(a)}(l = 0) = y_0 \), which is the initial mole fraction of \( O_2(a) \), the solution of (14) is

\[
y_{O_2(a)}(l) = \frac{y_0}{1 + \frac{y_0}{\Lambda} \cdot e^{-\Lambda l}} \quad (22)
\]

It can be quickly verified that \( y_{O_2(a)}(l \rightarrow \infty) = 0 \) and that \( y_{O_2(a)}(l \geq 0) > 0 \). For a very small wall deactivation coefficient so that \( \Lambda \cdot 1 \ll 1 \) and \( e^{\Lambda l} \equiv 1 + \Lambda \cdot l \), (22) simplifies to

\[
y_{i}(l) = \frac{y_0}{1 + y_0 \cdot \Theta(l)} \quad (23)
\]

Equation (23) was used to determine the \( O_2(a) \) concentration and yield-utilization product at the chip’s \( O_2(a) \) gas outlet from the measured values in the diagnostic region of the quartz cuvette.

According to (23), most of the \( O_2(a) \) is expected to have returned to the ground state by the time it reaches the measurement point, with pooling losses expected to dominate. In a real MEMS-based COIL, however, the mole fraction of \( O_2(a) \) is expected to be much higher at the point at which the iodine flow is injected in order to produce the lasing effect. In the present experiments, the significant deactivation that takes place before the measurements are made is a function of the scale mismatch between the \( \mu \)SOG and the macroscale diagnostic region, which results in a small value for \( v_{\text{gas}} \). In a scaled-up system of many arrayed \( \mu \)SOGs, the higher \( O_2(a) \) flow rates will increase \( v_{\text{gas}} \) and greatly reduce the deactivation as compared with the present experiments. Although some deactivation will still occur, it is expected that the amount of deactivation between the point of \( O_2(a) \) production and the chip’s exit port in the present experiments will be a better predictor of the deactivation that will occur in the internal flow paths that will ultimately connect the \( \mu \)SOGs to the rest of the MEMS COIL system.

### V. Experimental Procedure

The first step in the experiment is to prepare the BHP solution, which consists of equal parts 50 wt% aqueous KOH solution and 50 wt% \( \text{H}_2\text{O}_2 \). The external chiller is set at \(-20^\circ\text{C},\)
with the aim of the coolant reaching the rig at a temperature of 
−15 °C. The KOH solution was prepared by dissolving KOH 
pellets (Mallinckrodt, Phillipsburg, NJ) in deionized water. The 
KOH and H₂O₂ were slowly mixed together to ensure that the 
temperature never exceeded 25 °C. BHP and He flow were 
first initiated in the chip at atmospheric pressures. Gas and 
liquid flow were immediately visible in the reaction channels, 
and the capillary separator correctly functioned at the outset. 
The set points of the pressure controllers were then gradually 
lowered until the desired operating points were reached. The 
coolant flow was then started and increased until it reached its 
set point at around 5 °C. Once the set points of pressure and 
temperature had been reached, the chlorine, which is flowing 
concurrently with helium with a 3 : 1 ratio of He to Cl₂, was 
injected into the chip in pulses that were typically 1 min in 
length. The photonic emission coming out of the exit flow was 
measured using the spectrometric setup previously described, 
and the gas products were analyzed using a commercial mass 
spectrometer. After a number of runs, the remaining BHP 
was collected, and then the chip was warmed up (the coolant 
flow was stopped) while deionized water was flowed to ensure 
chip reutilization. After a few minutes of water flow, the chip 
was dismounted from the package, dried out using an oven, 
and stored for future use. Data were taken at 15 different 
operating points. The plenum pressure ranged from 50 to 
200 torr, and the total gas flow rate varied between 50 and 
200 sccm. Crystals of KCl were observed to form in the device 
channels after a number of runs (and in particular, after runs 
with very high ratios of chlorine gas to BHP) and eventually 
led to clogging in the device channels. The clogging, in turn, 
lessened the intensity of the spectral peaks with successive 
chlorine pulses. The implications of the observed clogging for 
the µSOG’s utility and for the analysis of the results are further 
discussed in Section VII. It was also observed that very little 
of the capillary separator area appeared to be used in removing 
clusive waste products, as expected from the considerable oversizing of 
the separator, as described earlier. This experimental fact will 
be important when discussing the O₂(α) yield and will also be 
discussed further in Section VII.

VI. Steady-State Validation and Dimol 
Emission Characterization

Confirmation of the steady-state operation of the chip was 
achieved by using two different diagnostics. The first diagnostic 
was measurement of the IR spectra. The IR spectra were 
recorded to monitor the O₂(α) emission. The typical temperature falls in the 
295–335-K range, in contrast with the subzero temperature of the chip.

Fig. 5. IR emission spectra from the µSOG versus time for a single 1-min chlorine pulse. The spectral intensity is given in arbitrary units.

shows the characteristic molecular band structure of the emission transition from O₂(α) to O₂(X) with a prominent Q-branch at the band center and weaker rotational branches on each side. Spectroscopic analysis of the detailed band shape gives the rotational temperature of the O₂(α), which is the same as the gas temperature for these conditions [10]. It is interesting to observe that although the chip is kept below 273 K, the O₂(α) at the detection point is at temperatures above 300 K. It is likely that the gas is warmed by a combination of conduction from the room-temperature optical measurement cell and energy released from the O₂(α) pooling reactions.

The second approach in determining the steady-state operation of the device used the mass spectrometer data (Fig. 8). The figure clearly shows a rise in the O₂ partial pressure roughly corresponding to the Cl₂ pulse. The increase in O₂ partial pressure appears approximately constant during the Cl₂ pulse, given the time-averaging effects of the long time constant for transport through the sampling capillary, thus indicating
steady-state operation. Attempts at quantitatively measuring the increase in O\textsubscript{2} mole fraction with mass spectrometry were hampered by limitations in the testing rig. Specifically, the low temperature of the LN\textsubscript{2} traps condensed out much of the O\textsubscript{2} in the gas stream along with the Cl\textsubscript{2}. The mass spectrometry therefore substantially underestimated the O\textsubscript{2} production, as evidenced by the fact that the amount of O\textsubscript{2}(a) detected by IR spectrometry at the measurement point (even without taking into account deactivation losses) sometimes exceeded the amount of total O\textsubscript{2} detected in the outlet flow by mass spectrometry.

The steady-state production of O\textsubscript{2}(a) masks an intricate fluid dynamics process, as shown in Fig. 9, where trickling rather than plug flow was observed in the reaction channels.

VII. DATA ANALYSIS: O\textsubscript{2}(a) YIELD, CHLORINE UTILIZATION, AND FLOW POWER

The O\textsubscript{2}(a) emission spectra were corrected for instrumental baseline and for the absolute spectral responsivity using the blackbody calibration results. The corrected spectra were integrated over the entire molecular band to determine the volumetric photon emission rate within the field of view. When this value is divided by the Einstein coefficient, which represents the rate at which O\textsubscript{2}(a) molecules decay into the O\textsubscript{2}(X) state ([28], [29]), the concentration of O\textsubscript{2}(a) is determined [10]. This concentration is an average over the field of view. The \(\mu\)SOG emission measurements were taken near the center of the quartz cuvette attached to the package, at a distance of approximately 3.05 cm from the gas outlet of the chip. Table III summarizes the conditions for each run, along with the measured concentrations at each point. The error in the measurements, around 13% for each run, results from uncertainty in the Einstein coefficient (10%) as well as from small uncertainties in the geometry of the setup. The measured O\textsubscript{2}(a) concentrations range from \(5 \times 10^{16}\) to \(1 \times 10^{17}\) cm\textsuperscript{-3}. The yield-utilization product, or the fraction of O\textsubscript{2} in the O\textsubscript{2}(a) state assuming 100% Cl\textsubscript{2} utilization, is also given in Table III. Ideally, the O\textsubscript{2}(a) concentration would be measured at the gas outlet, since that is the point at which the next stage of the laser system would be connected. Measurements are made further down the cuvette in this case in order to ensure that the field of view of the collimated optics is not obscured by the package or other parts of the test apparatus. Fortunately, (23) can be used to extrapolate the O\textsubscript{2}(a) concentration and yield-utilization product anywhere along the flow path given a concentration value downstream from that point, albeit with increasingly larger error bars. In this analysis, (23) is used to extrapolate the measured concentration and yield-utilization product up to the chip’s gas outlet. As was mentioned above, the values at the chip’s outlet are expected to be a better predictor of the performance of the \(\mu\)SOG chip in a complete MEMS COIL system than the value at the current measurement point is. The scale mismatch between the \(\mu\)SOG and the external diagnostic region in this case leads to low flow velocities and much greater O\textsubscript{2}(a) losses than would occur in a MEMS COIL system in which the components were integrated at the MEMS scale. When the measured values are extrapolated to the chip’s outlet using (23), the resulting values are substantially higher, with yield-utilization products approaching 80% and with the concentrations in most runs in excess of \(10^{17}\) cm\textsuperscript{-3}.

When the yield-utilization products extrapolated from the raw data were compared with those predicted by the baseline kinetics model described above, it became evident that some modification to the baseline model would be necessary in order to adequately explain the results. In most of the experimental runs, the extrapolation of the measured data produced higher but plausible values of the concentration and yield-utilization
product; however, in four of the runs, the extrapolation produced values of concentration and yield-utilization product that were not possible. In those four cases, the extrapolation indicated that there was more than one $O_2(a)$ molecule appearing at the chip’s gas outlet for each $Cl_2$ molecule that entered at the input, which is not possible. In some of these cases, even extrapolating the lower error bar for the measurement point produced unphysically high values for $O_2(a)$ concentration at the chip’s outlet.

Three sources of error were identified as possible contributors to the discrepancy. The first is clogging in the pressure drop and reaction channels, which is caused by KOH crystal precipitation and KCl salting, respectively. The second is the possibility that some of the output gas was sucked through open pores in the capillary separator rather than exiting through the gas outlet. The third is the documented uncertainty in the kinetics rate coefficients $k_2$ and $k_3$ that appear in the $\Theta$ coefficient in (23) [30]. Each of these three error mechanisms is discussed below; it will be seen that only the uncertainty in the pooling rate coefficients provides an adequate explanation of the discrepancy between the baseline model and the results.

Clogging of the flow channels was observed under two general conditions: when the chip had been operated for long periods of time with moderately high ratios of chlorine to BHP

<table>
<thead>
<tr>
<th>Run</th>
<th>He, (sccm)</th>
<th>$Cl_2$, (sccm)</th>
<th>BHP Flow Rate (cm$^3$/min)</th>
<th>$P_{\text{leak}}$ (torr)</th>
<th>$O_2^{(1/2)}$ Temp., (K)</th>
<th>Measured conc., (x10$^{17}$ cm$^{-3}$) (+/-13%)</th>
<th>Extrapolated initial conc., (x10$^{15}$ cm$^{-3}$)</th>
<th>Extrapolated initial yield-utilization product</th>
<th>Predicted initial yield-utilization product</th>
<th>Extrapolated Power, (W)</th>
<th>Molar Flow rate, (x10$^4$ mol s$^{-1}$ L$^{-1}$)</th>
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<td>13</td>
<td>0.95</td>
<td>100</td>
<td>330</td>
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<td>0.095</td>
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<td>0.7011</td>
<td>+0.3/-0.36</td>
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<td>18.75</td>
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<td>100</td>
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<td>1.04</td>
<td>0.144</td>
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<tr>
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<td>100</td>
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<td>0.95</td>
<td>0.132</td>
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<td>0.2987</td>
<td>+0.105/-0.08</td>
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</table>
and when the chip had been operated even for short times with particularly high ratios of chlorine to BHP. During operation, clogging was evidenced by a pressure rise on the gas feed lines for a given mass flow rate of feed gas. It is not surprising that clogging occurred in some of the runs. The $\mu$SOG was designed to operate with a ratio of BHP to chlorine that corresponds to a 10:1 ratio of peroxide ions to chlorine as compared with a many tens to one ratio that is used to prevent clogging in macroscale SOGs; a lower ratio corresponds to more efficient reactant usage. In practice, in these experiments, the chip was usually operated with a ratio of peroxide ions to chlorine in the range of approximately 3.7–13. It is reasonable to expect that some clogging would occur under these conditions, and to expect that increasing the BHP flow rate by a factor of 2 for a given chlorine flow rate would reduce or eliminate the clogging. The occurrence of clogging in some conditions and not in others also means that some of the runs may be considered to be a better indication of clog-free operation than others. In general, the most reliable data are considered to be the data that meet the following three criteria: they were taken toward the beginning of a given day’s measurements, they were taken at higher ratios of peroxide ions to chlorine, and there was no significant rise in gas feed pressure observed for given mass flow rate. When the 15 runs were judged according to these criteria, the four runs that yielded unphysically high extrapolated values of $O_2(a)$ at the chip’s outlet were found to suffer from minimal clogging. It is therefore expected that clogging will not provide an explanation for the observed discrepancy. In addition, the expected effect of clogging is not to increase the concentration of $O_2(a)$ at the chip’s outlet, but rather to decrease it. For a given mass flow rate set by the mass flow controllers, the effect of clogged channels like those shown in Fig. 10 is to increase the gas and liquid velocities within the remaining channels. This reduces the reactants’ residence time in the channels so that less $O_2(a)$ would be produced. Since the observed discrepancy is in the other direction (anomalously high concentrations), and since the runs with anomalously high concentrations are relatively free of clogging, clogging is rejected as an explanation for the observed discrepancy.

The second two potential sources of error (loss of $O_2(a)$ through the capillary separator and error in the pooling rate coefficients) were assessed by including them in a revised $\mu$SOG model and assessing whether including these effects could remove the discrepancy. In order to ensure that clogging was not affecting the comparison between model and experiments, the comparison was made for the four runs that were deemed to be the most free of clogging and for which the discrepancy was the largest. Two revisions to the baseline model were necessary. A fluidic circuit analogy was used to estimate the percentage of gas that was sucked through the separator holes along with the liquid waste. The fluidic circuit assumes incompressible fully developed flow in both the liquid and gas phases with a variable number of open holes $N$. The resulting loss of gas through the liquid separator is then accounted for in the calculation of the flow rates in the gas exit flow path. The model was also modified to account for the uncertainty of the pooling rate coefficients by making the effective pooling rate coefficient $2k_3 + k_2$ (or equivalently, $\Theta$) a variable parameter. In order to determine the best values for $\Theta$ and $N$, both parameters were independently varied, and the sum of squared errors between the model’s predicted concentrations at the measurement point and the measurements themselves were calculated for the four highest confidence runs. The best agreement between the kinetics model and the measured data, as shown in Fig. 11, occurred when $2k_3 + k_2$ was set at 84.5% of the published value, and gas leakage through the capillary separator was negligible. These corrected values for the rate coefficients fall within the error bars of the cited source reference for the kinetic constants [30]. Fig. 12 shows a pronounced drop in the error as the scalar multiplier of $\Theta$ is varied. This is not a unique minimization in the 2-D ($\Theta$, $N$) space. Similar minima are obtained for nonzero values of $N$, but they correspond to still smaller values of the pooling rate coefficient. The best agreement occurs (and minimum modification to $2k_3 + k_2$ is necessary) when $N$ approaches zero, suggesting that the occasional gas bubbles that were observed flowing through the separator’s liquid outlet line
had a negligible effect on the measurement. In other words, if significant O$_2$(a) flows were sucked in by the separator, the flow velocity in the gas outlet would be still smaller. As a result, $k_2$ and $k_3$ would also need to be even smaller to give physically meaningful predictions at the chip’s O$_2$(a) outlet. However, it is possible to have a small O$_2$(a) separator leak and still have pooling rate coefficient values that fall within the error bars of the reference and essentially yield the same minimum error.

As was described before, only a small fraction of the separator seems to be covered by the wetting front of the liquid byproducts. Given the pressure difference applied across the capillary separator, even a small number of capillaries (5% of the total number) that were not filled with liquid would have been enough to suck in all the O$_2$(a) and prevent any observation of O$_2$(a) at the measurement point. The experimental performance suggests that the separator worked as designed, and the capillaries that did not appear to be used during operation were nonetheless plugged with a stationary film of BHP that was put in place when BHP was first flowed through the chip. In all cases, the pressure difference across the separator is not enough to overcome the surface tension effects and clear the capillaries of liquid to allow for penetration of gas into the liquid exit flow.

The adjusted values for the pooling rate coefficients were used to calculate molar flow rates per unit of reactor volume and power in the O$_2$(a) flow as well as yield-utilization product and O$_2$(a) concentration at the chip’s gas outlet. These values are also shown in Table III. The maximum yield-utilization product at the chip’s gas outlet is determined to be 78% (+21% and −43%). This is theoretically consistent with a chlorine utilization of 100% and a yield of 78%, a chlorine utilization of 78% and a yield of 100%, or anywhere between. The lack of quantitative mass spectrometer data makes independent determination of the yield and chlorine utilization impossible. However, given that some pooling losses must have taken place between the end of the reaction channels and the chip’s gas outlet, it is reasonable to conclude that this corresponds to a chlorine utilization of near 100% and a yield of about 78%.

![Fig. 12. Minimum square error sum versus scalar multiple of Θ for the data set with the highest confidence level. There is a range of possible kinetic constants and O$_2$(a) separator leak that yield equivalent minimum error, but all combinations point toward small O$_2$(a) bleed.](image)

This yield is in line with state-of-the-art jet SOGs, which have been reported to perform with yields as high as 73% [31], [32]. High yield is particularly important in COIL reactors because some O$_2$(a) is consumed in the dissociation of I$_2$ and, of the remainder, only O$_2$(a) above the threshold yield of about 7% can contribute at all to laser output in a COIL system; incremental increases above the onset of lasing offer significant increases in power because of the dynamics of the COIL system.

A comparison of O$_2$(a) molar flow rate per unit volume between the μSOG and other technologies is given in Table IV. The maximum molar flow rate of O$_2$(a) per unit reactor volume is about $670 \times 10^{-4}$ mol/L/s. This value includes that part of the volume of the MEMS chip that hosts the manifolds, reaction channels, and capillary separator; it does not include any volume that is solely devoted to single-chip packaging or the volume that is devoted to chip cooling. This favorably compares with the molar flow rate of O$_2$(a) per unit of reactor volume for various types of published SOGs, as reported in the literature. The molar flow rate per unit of internal reactor volume for modern jet SOGs is about 1300–1700 $\times 10^{-4}$ mol/L/s [31], [33], nearly three times as large as the molar flow rate per unit of reactor hardware volume reported here for the μSOG chip. However, it should be noted that the μSOG volume includes the bifurcated BHP inlet as well as some of the surrounding silicon, whereas the jet SOG values only take the internal reaction volume into account.

The power carried by the flow of O$_2$(a) at the μSOG’s gas outlet may be estimated from the molar flow rate extrapolated to the gas outlet and the energy of the O$_2$(a $\rightarrow$ X) transition. The resulting values for power in the flow are reported in Table III. The maximum per chip power in the output flow is 1.37 W. However, only part of the power in the O$_2$(a) flow would be converted to laser output power if μSOG chips were used to drive a COIL system. Assuming a threshold yield of 7% and a typical COIL power extraction efficiency of 80% [34], the power in each μSOG’s O$_2$(a) flow is predicted to source about 1 W of laser output power when integrated into an appropriate COIL system. The original μSOG study [3] had proposed using arrays of microdevices to construct COIL systems with power levels ranging from several kilowatts to 100 kW. In that study, each μSOG chip was predicted to drive 2.3 W of this power output. The maximum power capability of 1.37 W per chip demonstrated in the present experiments is in agreement with the model predictions but is somewhat less than the optimum of 2.3 W per chip as identified in the initial modeling study. The difference between the predicted optimum performance and the performance demonstrated in the first μSOG chips is...
not surprising, given that the chips have not yet been operated at their optimum operating point because of flow limitations in the initial test rig. It is expected that the performance of the µSOG chips will approach the predicted optimum performance more closely as they are demonstrated closer to their optimum operating point. In particular, it is expected that the output of O$_2$(a) per chip will increase and that clogging will decrease when the chips are operated at higher BHP and chlorine flow rates and at higher BHP to chlorine ratios.

VIII. CONCLUSION

Generation of O$_2$(a) using a MEMS SOG has been successfully demonstrated. The devices were tested over a range of operating points, resulting in O$_2$(a) molar flow rates in excess of 600 mol/Ls and a yield-utilization product approaching 80%. On both of these crucial metrics, the µSOG showed performance that favorably compares with the macroscaled SOGs that are described in the published literature. Future work includes testing multiple µSOGs in tandem at their optimal operating conditions and using arrays of µSOGs to drive a MEMS COIL system.

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REFERENCES

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